

Application/Control No.	Applicant(s)/Patent under Reexamination
10/634,694	LIM ET AL.
Examiner	Art Unit
Dmitry Levitan	2616

SEARCHED				
Class	Subclass	Date	Examiner	
320	254,			
200	255			
	464			
	474-			
	477			
	431-	5/-	107	
	433	172		
	437			
359	109			
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709	220-	1		
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INTERFERENCE SEARCHED					
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